

**Patent Claims**

1           1. A hard metal substrate body comprised of a WC hard  
2 material phase and a binder phase of 3 to 25 mass % which apart  
3 from at least one of the binder metals Fe, Co and/or Ni contains up  
4 to 15 mass % of the binder phase dissolved dopant selected from the  
5 group comprised of Al, Cr, V, Nb, Ta, Ti, Zr, Hf, characterized in  
6 that the percentage proportion of all doping agents in the hard  
7 metal is limited to a maximum of 4 mass % in that the proportion of  
8 a cubic phase in the hard metal is less than 4 volume % and in that  
9 the binder metal content in a hard metal-substrate body boundary  
10 zone falls from up to 1  $\mu\text{m}$ , preferably up to 0.5  $\mu\text{m}$  to less than  
11 0.5 times the binder content in the substrate body interior.

1           2. The hard metal substrate body according to claim 1  
2 characterized in that the concentration of the binder phase falls  
3 gradually toward the substrate body surface and the concentration  
4 of the dopant gradually increases in a corresponding manner.

1           3. The hard metal substrate body according to claim 1 or  
2 characterized in that the grain size of the WC is  $\leq 1.5 \mu\text{m}$   
3 whereby the WC fine hard metal (grain size  $\leq 0.8 \mu\text{m}$ ) and/or with WC  
4 ultrafine grain hard metal (grain size  $\leq 0.5 \mu\text{m}$ ), preferably  
5 contain Cr, V and/or Ta as dopant.

1           4. The hard metal substrate body characterized in that  
2   at least one layer is applied to the substrate body surface, the  
3   layer being comprised of a carbide, nitride and/or carbonitride of  
4   Ti, Zr and/or Hf and/or of  $\text{Al}_2\text{O}_3$ ,  $\text{HfO}_2$ ,  $\text{ZrO}_2$ , oxides, amorphous  
5   carbon, diamond, cubic boron nitride, carbon nitride ( $\text{CN}_x$ ) or  
6   another compound of at least one of the elements B, C, N and/or O.

1           5. The hard metal substrate body according to claims 1  
2   to 4 characterized in that in the boundary zone close to the  
3   surface there is an enrichment with nitride or carbonitride of the  
4   metal dopant.

1           6. A method of producing a hard metal substrate body  
2   according to one of claims 1 to 5 in which the starting mixture is  
3   preheated powder metallurgically is prepressed to a green body and  
4   then in an atmosphere of a furnace is heated and sintered,  
5   characterized in that in the heating phase, after reaching the  
6   eutectic, but no later than reaching the sintering temperature the  
7   vacuum or inert gas atmosphere is replaced with a  $\text{N}_2$  atmosphere  
8   with a  $\text{N}_2$  pressure of  $\leq 10^5$  Pa and is maintained at least until the  
9   sintering temperature is reached.

1           7. The method of making a hard metal substrate body  
2   according to one of claims 1 to 5 in which the starting mixture is  
3   powder metallurgically treated and is pressed to a green body and

4 finally heated in an atmosphere of a furnace and sintered,  
5 characterized in that after finish sintering or optionally in a  
6 final treatment above the eutectic temperature, the sintered body  
7 is maintained in a N<sub>2</sub> atmosphere under a pressure (p) of 10<sup>5</sup> Pa < p  
8 < 10<sup>7</sup> Pa for at least 10 minutes.

1 8. The method according to claim 6 or 7 characterized in  
2 that the nitrogen atmosphere is established by introducing  
3 precursors that is N-containing gases whereby the nitrogen is  
4 formed *in situ* in the gas atmosphere.

1 9. The method according to one of claims 6 to 8  
2 characterized in that the body is heated up to 1250°C during the  
3 heating phase and this temperature is held for at least 20 minutes,  
4 preferably more than 1 hour, before the heating up is continued to  
5 the sintering temperature.

6 10. The method according to one of claims 6, 8 or 9  
7 characterized in that initially in the heating up phase at about  
8 1200°C the previously existing vacuum is replaced by an inert gas  
9 atmosphere, preferably with a pressure of 10<sup>3</sup> Pa to 10<sup>4</sup> Pa and only  
10 upon reaching the sintering temperature is a nitrogen containing  
11 atmosphere established with a higher pressure, preferably  $\geq 10^4$  Pa.

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1 11. The method according to one of claims 6 to 10  
2 characterized in that the heating up rate and the cooling down rate  
3 amounts to up to 10°C/min, preferably between 2°C/min and 5°C/min.

1                   12. The method according to one of claims 6 to 11  
2 characterized in that the starting mixture contains up to 15 mass %  
3 of the binder phase additional carbides, nitrides, carbonitrides of  
4 the elements of Group IVa or VIa of the periodic system or Al or  
5 complex carbides, complex nitrides and/or complex carbonitrides of  
6 the form Ti<sub>x</sub>AlC, Ti<sub>x</sub>AlN, Cr<sub>x</sub>AlN, Cr<sub>x</sub>AlC.